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Substitute for form 1449A/B/PTO				Complete If Known	
				Application Number	10/733,523-Conf. #9060
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)				Filing Date	December 10, 2003
				First Named Inventor	Kevin L Beaman
				Art Unit	1762
				Examiner Name	D. P. Turocy
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U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			
DA		US-10/767,298	Filed 01-28-2004	Zheng et al.	
		US-11/027,825	Filed 12-29-2004	Derderian et al.	
		US-10/933,604	Filed 09-02-2004	Carpenter et al.	
		US-10/687,458	Filed 10-15-2003	Kubista et al.	
		US-10/683,424	Filed 10-10-2003	Mardian	
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		US-10/814,573	Filed 03-31-2004	Gealy et al.	
		US-11/043,629	Filed 01-25-2005	Rueger et al.	
		US-11/018,142	Filed 12-20-2004	Rueger et al.	
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		US-11/027,809	Filed 12-29-2004	Carpenter et al.	
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		US-3,630,881	12-28-1971	Lester et al.	
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		US-3,634,212	01-11-1972	Valayll et al.	
		US-4,018,949	04-19-1977	Donokowski et al.	
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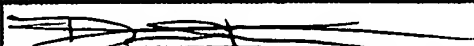
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25	US-4,269,625	05-26-1981	Molenaar	
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	US-4,681,777	07-21-1987	Engelken et al.	
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	US-5,380,396	01-10-1995	Shikida et al.	
	US-5,409,129	04-25-1995	Tsukada et al.	
	US-5,418,180	05-23-1995	Brown	
	US-5,427,666	06-27-1995	Mueller et al.	
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	US-5,445,491	08-29-1995	Nakagawa et al.	
	US-5,480,818	01-02-1996	Matsumoto et al.	
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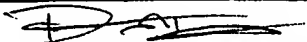
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55	US-5,500,256	03-19-1996	Watabe	
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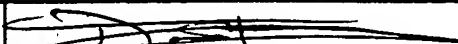
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	US-6,193,802	02-27-2001	Pang et al.	
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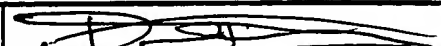
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5	US-2001/0029892-A1	10-18-2001	Cook et al.	
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				Application Number	10/733,523-Conf. #9060
				Filing Date	December 10, 2003
				First Named Inventor	Kevin L Beaman
				Art Unit	1762
				Examiner Name	D. P. Turocy
Sheet	9	of	13	Attorney Docket Number	108298718US

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				Application Number	10/733,523-Conf. #9060
				Filing Date	December 10, 2003
				First Named Inventor	Kevin L Beaman
				Art Unit	1762
				Examiner Name	D. P. Turocy
Sheet	10	of	13	Attorney Docket Number	108298718US

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				Application Number	10/733,523-Conf. #9060
				Filing Date	December 10, 2003
				First Named Inventor	Kevin L Beaman
				Art Unit	1762
				Examiner Name	D. P. Turocy
				Attorney Docket Number	108298718US
Sheet	11	of	13		



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NON PATENT LITERATURE DOCUMENTS				
Examiner Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.		
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				Application Number	10/733,523-Conf. #9060
				Filing Date	December 10, 2003
				First Named Inventor	Kevin L Beaman
				Art Unit	1762
				Examiner Name	D. P. Turocy
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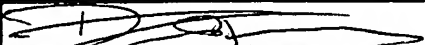
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				Art Unit	1762
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Sheet	13	of	13	Attorney Docket Number	108298718US

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